

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicant : Paul D. Shirley

Serial No. : 10/773,968

Filed : February 6, 2004

Title : **DEVICE AND METHOD FOR FORMING IMPROVED RESIST LAYER**

Docket : MIO 0112 PA/40509.272

Examiner : Laura E. Edwards

Art Unit : 1792

Conf. No. : 7341

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

EFS Web Electronic Submission

July 30, 2008

Sir:

**RESPONSE UNDER 37 CFR 1.116**

This paper is being filed in response to the Office Action mailed on June 27, 2008. Reconsideration of the present application is respectfully requested in light of the remarks below.